

No Directionality
to Hot wire.
Single wire.

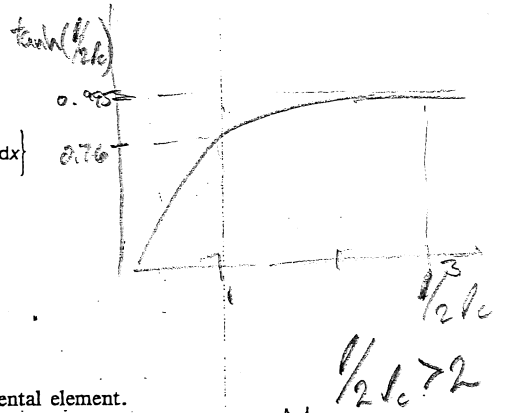
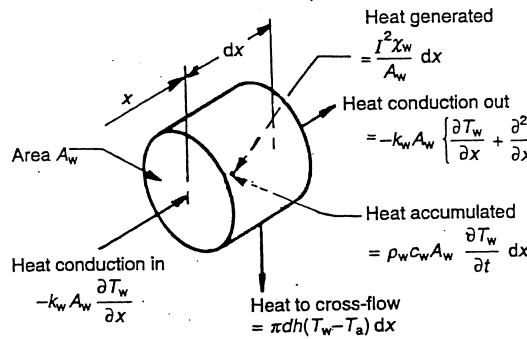
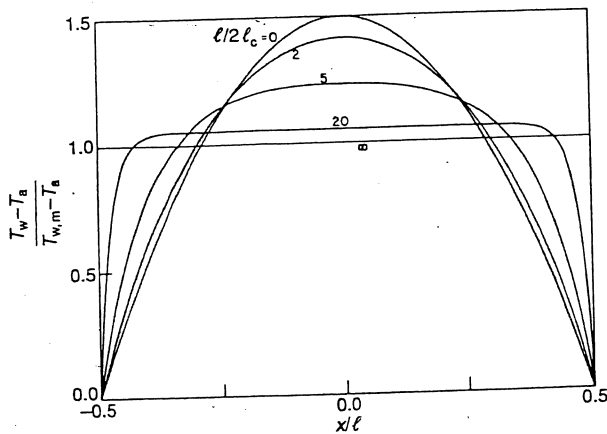
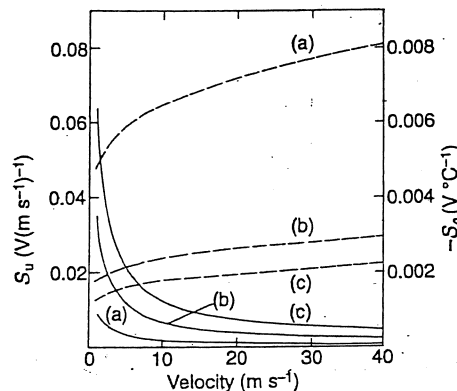


Fig. 2.1. The hot-wire geometry and heat balance for an incremental element.



$$l_c = \frac{d_w}{2} \left[\frac{R_w}{k_f} \frac{R_w}{R_a} \frac{1}{Nu} \right]^{1/2}$$

$$q_{cond} = \frac{2 k_w A_c (T_{w\infty} - T_a) \tanh(l/2l_c)}{l_c}$$

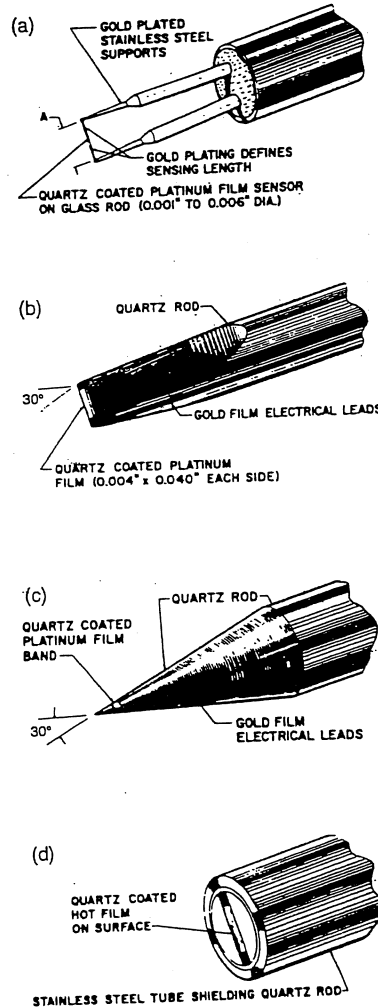


Subscript θ refers to
temperature

Fig. 2.3. The variation in (—) the velocity and (---) the temperature sensitivity with velocity and for temperature differences $T_w - T_a$ of: (a) 10 °C, (b) 100 °C and (c) 250 °C.

Companies that make hot wires
TSI
Dantech

Thin (0.1 μm) Pt or Ni films deposited on insulating substrate (quartz). This film is usually coated with 1-2 μm thick insulating material such as quartz - use in liquids made possible.
20-70 μm ϕ & 1-2 mm long



- surface measurements

Fig. 2.4. Hot-film probe types: (a) cylindrical, (b) wedge, (c) cone, and (d) flush mounted. (Reprinted with the permission of TSI Inc.)

TABLE 2.1 Physical properties of common hot-wire materials

Material	Ultimate tensile strength (N cm^{-2})	Temperature coefficient of resistivity, α_{20} ($^{\circ}\text{C}^{-1}$)	Resistivity, χ_{20} ($\mu\Omega \text{ cm}$)	Thermal conductivity, k_w ($\text{W cm}^{-1} ^{\circ}\text{C}^{-1}$)	Density, ρ_w (kg m^{-3})	Specific heat, c_w ($\text{kJ kg}^{-1} ^{\circ}\text{C}^{-1}$)	Available as Wollaston wire?	Melting point ($^{\circ}\text{C}$)	Comments
Tungsten	250 000	0.0036	5.5	1.9	19 300	0.14	No	3410	Oxidizes above 350 $^{\circ}\text{C}$, cannot be soldered
Platinum	35 000	0.0038	9.8	0.7	21 500	0.13	Yes	1770	Soft and weak
Platinum-rhodium (90-10%)	70 000	0.0016	19	0.4	19 900	0.15	Yes	1830	Stronger than Pt
Platinum-iridium (80-20%)	140 000	0.0008	32	0.17	21 600	0.13	Yes	1840	Stronger than Pt

Wollaston wires: Pt covered with Ag & drawn thru a die. Wire is then soldered or welded to progs & Pt is exposed by etching the Ag sheath.

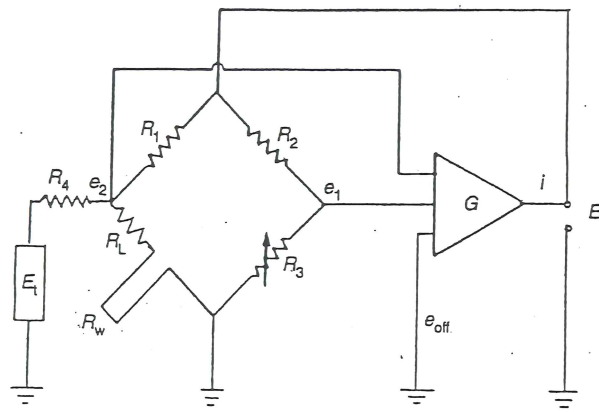


Fig. 2.12. A *CT* anemometer containing a Wheatstone bridge, a feedback amplifier, and an electronic-testing subcircuit.

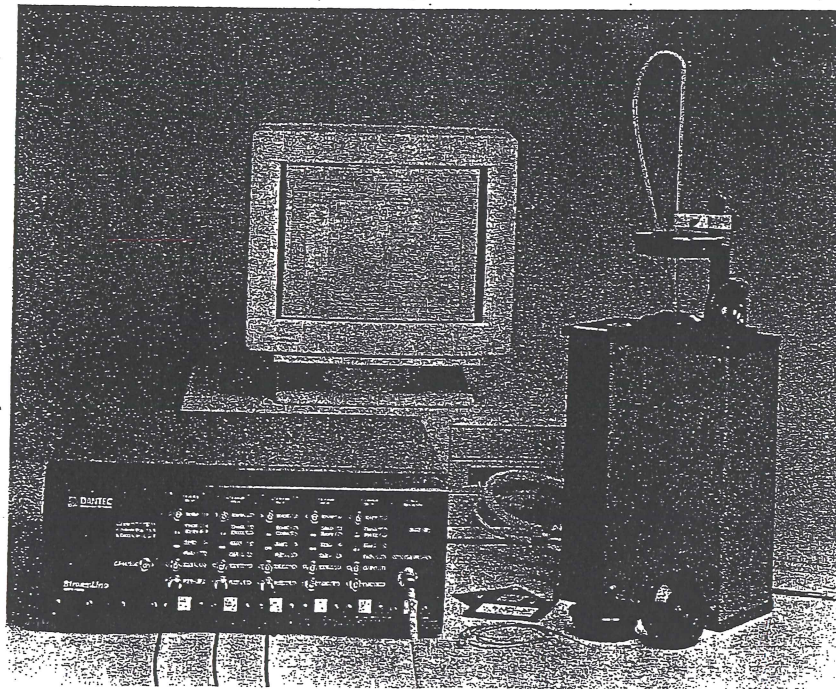


Fig. 2.13. A computer-controlled *CT* anemometer and a nozzle calibration facility. (Reprinted with the permission of DANTEC Measurement Technology.)

